

*#17/c PB
m/e*

PATENT APPLICATION

RESPONSE UNDER 37 CFR §1.116 *11-27-03*

EXPEDITED PROCEDURE

TECHNOLOGY CENTER ART UNIT 2825

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi TAKANO

Group Art Unit: 2825

Application No.: 09/819,690

Examiner: G. Lee

Filed: March 29, 2001

Docket No.: 109107

For: SEMICONDUCTOR MANUFACTURING METHOD, SUBSTRATE PROCESSING
METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the June 3, 2003 Office Action, the shortened statutory period for reply
being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims;

Remarks.

DO NOT ENTER *6/13/03*

DO NOT ENTER